

L Number	Hits	Search Text	DB	Time stamp
9	0	(semiconductor near fiber) and (ball near2 lens) and (oxidi\$4 near aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/09 11:19
16	2	(semiconductor near fiber) and (ball near2 lens) and ((fabry near perot) or fp) and (DFB or (distributed near feed near back))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/09 11:20
	1	(semiconductor near laser) and shaper and (oxidi\$4 near aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 07:22
	1	(semiconductor near laser) and shaper and (oxidi\$4 near aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 08:20
	85	(semiconductor near laser) and (oxidi\$4 near aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 08:02
	13	((semiconductor near laser) and (oxidi\$4 near aluminium)) and optical near fiber	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 08:02
	25	((semiconductor near laser) and (oxidi\$4 near aluminium)) and fiber	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 09:43
	23	(semiconductor near laser) and shape and (oxidi\$4 near aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 08:22
	10	((semiconductor near laser) and shape and (oxidi\$4 near aluminium)) and fiber	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 08:23
	2	(semiconductor near laser) and (beam near shape) and (oxidi\$4 near aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 08:22
	12	((semiconductor near laser) and (oxidi\$4 near aluminium)) and fiber) and lens	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 09:35

	286	(semiconductor near laser) and (mirror near (concave or convex)) and fiber	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 09:45
	22	(semiconductor near laser) and (mirror near aluminium) and fiber	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 09:49
	7	((semiconductor near laser) and (mirror near aluminium) and fiber) and ((semiconductor near laser) and (mirror near (concave or convex)) and fiber)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 09:46
	0	(semiconductor near laser) and (lens near aluminium) and fiber	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 09:49
	1	(semiconductor near laser) and (lens near aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 09:51
	62	(semiconductor near laser) and (shap\$3 near2 aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 10:07
	25	(semiconductor near laser) and (shap\$3 near aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 09:58
	26	(semiconductor near laser) and ((shap\$3 or lens) near aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 09:59
	72	(semiconductor near laser) and ((shap\$3 or lens) near2 aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 10:12
	485	(semiconductor near laser) and ((shap\$3 or lens) WITH aluminium)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 10:13
	112	(semiconductor near laser) and ((shap\$3 or lens) WITH aluminium) and (trench or groove)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 10:14
	34	(semiconductor near laser) and ((shap\$3 or lens) WITH aluminium) and (trench or groove) AND FIBER	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 10:44

	1864	((semiconductor near laser) and (shape\$3 or lens) and (trench or groove) AND FIBER	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 10:46
	660	((semiconductor near laser) and (shape\$3 or lens) and (trench or groove) AND FIBER) AND 372/\$	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 10:46
	594	((semiconductor near laser) and (shape\$3 or lens) and (trench or groove) AND FIBER) AND aluminium	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 14:29
	43	((semiconductor near laser) and (shape\$3 or lens) and (trench or groove) AND FIBER) AND aluminium and ((fabry near perot) or fp) and (DFB or (distributed near feed near back))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 11:24
	79	((semiconductor near laser) and (shape\$3 or lens) and (trench or groove) AND FIBER) AND aluminium near oxid\$4	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 14:30
	6	((semiconductor near laser) and (shape\$3 or lens) and (trench or groove) AND FIBER) AND aluminium near oxid\$4) and (((semiconductor near laser) and (shape\$3 or lens) and (trench or groove) AND FIBER) AND aluminium) and ((fabry near perot) or fp) and (DFB or (distributed near feed near back)))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 14:30
	193	(semiconductor near laser) and (ball near2 lens)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 15:29
	1113	(semiconductor near laser) and (convex or (convex near (mirror or lens))) and (optical near element)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 15:18
	0	(semiconductor near laser) and ((convex or concave) near beam near shaper)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 15:19
	20	((semiconductor near laser) and (convex or (convex near (mirror or lens))) and (optical near element)) and ((semiconductor near laser) and (ball near2 lens))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 15:28
	1	((semiconductor near laser) and (convex or (convex near (mirror or lens))) and (optical near element)) and ((semiconductor near laser) and (ball near2 lens)) and 372/92	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 15:29

	0	((semiconductor near laser) and (convex or (convex near (mirror or lens))) and (optical near element)) and ((semiconductor near laser) and (ball near2 lens)) and 372/99	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 15:28
	0	((semiconductor near laser) and (convex or (convex near (mirror or lens))) and (optical near element)) and ((semiconductor near laser) and (ball near2 lens)) and 372/6	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/08 15:29
	16	(semiconductor near fiber) and (ball near2 lens)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2003/04/09 10:42